CLAIMS

What is claimed is:

1 1. A spin valve (SV) sensor comprising:

2 a pinned layer having a pinned layer magnetization;

3 a free layer disposed adjacent the pinned layer, the free layer having a free layer magnetization perpendicular to the pinned layer magnetization in the absence

of an external field;

6 a spacer layer disposed between the free layer and the pinned layer;

a pinning layer disposed adjacent the pinned layer for fixing the pinned layer

8 magnetization;

9 an underlayer disposed adjacent the pinning layer, the underlayer comprising

10 NiFeX; and

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an upper layer disposed adjacent the underlayer and the pinning layer, the 11

12 upper layer comprising a material selected from the group consisting of NiFe and

CoFe for increasing a GMR ratio associated with the SV sensor. 13

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The spin valve sensor as recited in claim 2, wherein the upper layer has a

The spin valve sensor as recited in claim 5, wherein the upper layer has a thickness of no more than 20 A.

The spin valve sensor as recited in claim 1, wherein the upper layer is doped.

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- 5. The spin valve sensor as recited in claim 1, wherein the underlayer comprises

 NiFeCr.
- 1 6. The spin valve sensor as recited in claim 1, wherein the SV sensor is a
- 2 component of a disk drive system. Lol lines 21-22
- 1 7. The spin valve sensor as recited in claim 1, wherein the underlayer includes
- 2 40 +/- 5 Atomic % Cr. \ Co \ 8 | 1 nes 1-
- 1 8. The spin valve sensor as recited in claim 1, wherein the pinned layer
- 2 comprises a Ru layer.
- 1 9. The spin valve sensor as recited in claim 8, wherein the pinned layer further
- 2 comprises a first CoFe layer disposed adjacent a first side of the Ru layer and
- a second CoFe layer disposed adjacent a second side of the Ru layer.
- 1 10. The spin valve sensor as recited in claim 1, wherein the free layer comprises
- 2 a NiFe layer. 150
- 1 11. The spin valve sensor as recited in claim 10, wherein the free layer further
- 2 comprises a CoFe layer disposed adjacent the NiFe layer. 152, 148

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	1	12. A method of fabricating a spin valve (SV) sensor comprising:
	2	depositing an underlayer comprising NiFeX;
	$\sqrt{3}$	depositing an upper layer adjacent the underlayer, the upper layer comprising
γ_{∞}	\\\ \\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\	a material selected from the group consisting of NiFe and CoFe for increasing a
$C\eta_0$	5	GMR ratio associated with the SV sensor;
	6	depositing a pinning layer adjacent the upper layer;
	7	depositing a pinned layer adjacent the pinning layer, the pinned layer having
	8	a pinned layer magnetization;
	9	depositing a spacer layer adjacent the pinned layer; and
	10	depositing a free layer adjacent the pinned layer, the free layer having a free
	11	layer magnetization perpendicular to the pinned layer magnetization in the absence
The state of the s	12	of an external field. Some as product
	12	
	12	13. The method as recited in claim 12, wherein the upper layer has a thickness of
	12	
		13. The method as recited in claim 12, wherein the upper layer has a thickness of at least 4 A.
g an in		 13. The method as recited in claim 12, wherein the upper layer has a thickness of at least 4 A. 14. The method as recited in claim 13, wherein the upper layer has a thickness of
		13. The method as recited in claim 12, wherein the upper layer has a thickness of at least 4 A.
g an in		 13. The method as recited in claim 12, wherein the upper layer has a thickness of at least 4 A. 14. The method as recited in claim 13, wherein the upper layer has a thickness of no more than 20 A.
Company of the state of the sta	1 1 2 1 2 2 1 2 2 2 2 2 2 2 2 2 2 2 2 2	 13. The method as recited in claim 12, wherein the upper layer has a thickness of at least 4 A. 14. The method as recited in claim 13, wherein the upper layer has a thickness of
Company of the state of the sta	1 1 2 1 2 2 1 2 2 2 2 2 2 2 2 2 2 2 2 2	 13. The method as recited in claim 12, wherein the upper layer has a thickness of at least 4 A. 14. The method as recited in claim 13, wherein the upper layer has a thickness of no more than 20 A. 15. The method as recited in claim 12, wherein the upper layer is doped.
g an in	1 1 2 1 2 2 1 2 2 2 2 2 2 2 2 2 2 2 2 2	 13. The method as recited in claim 12, wherein the upper layer has a thickness of at least 4 A. 14. The method as recited in claim 13, wherein the upper layer has a thickness of no more than 20 A.

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1	17. A spin valve (SV) sensor comprising:
2	pinned layer having a pinned layer magnetization;
3	a free layer disposed adjacent the pinned layer, the free layer having a free
4	layer magnetization perpendicular to the pinned layer magnetization in the absence
1 5	of an external field;
\ 6	a spacer layer disposed between the free layer and the pinned layer;
7	a pinning layer disposed adjacent the pinned layer for fixing the pinned layer
8	magnetization, the pinning layer comprising PtMn;
9	an underlayer disposed adjacent the pinning layer, the underlayer comprising
10	NiFeCr; and
11	an upper layer disposed adjacent the underlayer and the pinning layer, the
12	upper layer comprising CoFe for increasing a GMR ratio associated with the SV
13	sensor. 103
1	18. A spin valve (SV) sensor comprising:
2	a pinned layer having a pinned layer magnetization;
3	a free layer disposed adjacent the pinned layer, the free layer having a free
4	layer magnetization perpendicular to the pinned layer magnetization in the absence
5	of an external field;
6	a spacer layer disposed between the free layer and the pinned layer;
7	a pinning layer disposed adjacent the pinned layer for fixing the pinned layer

magnetization, the pinning layer comprising PtMn;

9	an underlayer disposed adjacent the pinning layer, the underlayer comprising
10	NiFeCr; and
11	an upper layer disposed adjacent the underlayer and the pinning layer, the
12	upper layer comprising NiFe for increasing a GMR ratio associated with the SV
13	sensor.
1	19. A spin valve (SV) sensor comprising:
2	a pinned layer having a pinned layer magnetization;
3	a free layer disposed adjacent the pinned layer, the free layer having a free
4	layer magnetization perpendicular to the pinned layer magnetization in the absence
5	of an external field;
6	a pinning layer disposed adjacent the pinned layer for fixing the pinned layer
7	magnetization;
8	an underlayer disposed adjacent the pinning layer, the underlayer comprising
9	NiFeCr; and
10	an upper layer disposed adjacent the underlayer and the pinning layer, the
11	upper layer comprising a material selected from the group consisting of NiFe and
12	CoFe for increasing a GMR ratio associated with the SV sensor;
13	wherein the upper layer has a thickness between 4 A and 20A.

A spin valve (SV) sensor comprising:

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2	a pinned layer having a pinned layer magnetization, the pinned layer
3	comprising a Ru layer with a first CoFe layer disposed adjacent a first side of the Ru
4	layer and a second CoFe layer disposed adjacent a second side of the Ru layer;
5	a free layer disposed adjacent the pinned layer, the free layer having a free
6	layer magnetization perpendicular to the pinned layer magnetization in the absence
7	of an external field, the free layer comprising a NiFe layer with a third CoFe layer
8	disposed adjacent thereto;
9	a spacer layer disposed between the free layer and the pinned layer;
10	a pinning layer disposed adjacent the pinned layer for fixing the pinned layer
11	magnetization, the pinning layer comprising PtMn;
12	an underlayer disposed adjacent the pinning layer, the underlayer comprising
13	NiFeCr; and
14	an upper layer disposed adjacent the underlayer and the pinning layer, the
15	upper layer comprising a material selected from the group consisting of NiFe and
16	CoFe for increasing a GMR ratio associated with the SV sensor.
1	21. A disk drive system, comprising: heart struck c
2	a magnetic recording disk;
3	a spin valve (SV) sensor including:
4	a pinned layer having a pinned layer magnetization;
5	a free layer disposed adjacent the pinned layer, the free layer having a
6	free layer magnetization perpendicular to the pinned layer magnetization in
7	the absence of an external field,

